



US007123416B1

(12) **United States Patent**
Erdogan et al.

(10) **Patent No.:** **US 7,123,416 B1**
(45) **Date of Patent:** ***Oct. 17, 2006**

(54) **METHOD OF MAKING HIGH PERFORMANCE OPTICAL EDGE AND NOTCH FILTERS AND RESULTING PRODUCTS**

(75) Inventors: **Turan Erdogan**, Spencerport, NY (US);
Joseph T. Foss, Rochester, NY (US);
Ligang Wang, Rochester, NY (US)

(73) Assignee: **Semrock, Inc.**, Rochester, NY (US)

(*) Notice: Subject to any disclaimer, the term of this patent is extended or adjusted under 35 U.S.C. 154(b) by 0 days.

This patent is subject to a terminal disclaimer.

(21) Appl. No.: **11/248,456**

(22) Filed: **Oct. 11, 2005**

Related U.S. Application Data

(63) Continuation-in-part of application No. 10/840,134, filed on May 6, 2004.

(60) Provisional application No. 60/637,697, filed on Dec. 21, 2004, provisional application No. 60/468,245, filed on May 6, 2003.

(51) **Int. Cl.**
G02B 5/28 (2006.01)
G02B 1/10 (2006.01)

(52) **U.S. Cl.** **359/589**; 359/588; 359/580; 359/587

(58) **Field of Classification Search** 359/589, 359/588, 580, 587

See application file for complete search history.

(56) **References Cited**

U.S. PATENT DOCUMENTS

- 4,142,958 A 3/1979 Wei et al.
- 4,793,908 A 12/1988 Scott et al.
- 5,112,127 A 5/1992 Carrabba et al.

- 5,512,131 A 4/1996 Kumar et al.
- 5,656,138 A 8/1997 Scobey et al.
- 5,712,715 A 1/1998 Erdogan et al.
- 5,828,489 A * 10/1998 Johnson et al. 359/487
- 5,900,160 A 5/1999 Whitesides et al.
- 6,518,168 B1 2/2003 Clem et al.
- 6,623,803 B1 9/2003 Krivokapic
- 6,649,208 B1 11/2003 Rodgers
- 6,704,130 B1 3/2004 Ford et al.
- 6,809,859 B1 10/2004 Erdogan et al.
- 2005/0110999 A1 5/2005 Erdogan et al.

OTHER PUBLICATIONS

Becker, J., "Ion-Beam Sputtering," Handbook of Optical Properties, vol. 1, Thin Films for Optical Coatings, Ed. By R.E. Hummel and K.H. Guenther, Chapter 7, pp. 189-211, (CRC Press, Boca Raton, 1995).

Macleod, H. Angus, "Thin-Film Optical Filters," 3rd Ed., Institute of Physics (2001).

(Continued)

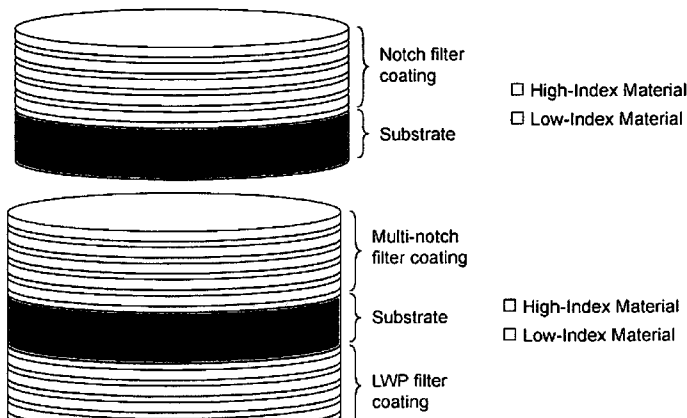
Primary Examiner—Fayez G. Assaf

(74) *Attorney, Agent, or Firm*—Lowenstein Sandler PC

(57) **ABSTRACT**

High performance optical edge and notch filters and methods of making the same are disclosed. The multi-layer, thin-film optical edge filters have an edge steepness greater than about 0.8% as measured by dividing (a) the edge width from the 50% transmission wavelength to the optical density 6 ("OD6") wavelength by (b) the 50% transmission wavelength. The optical edge filters also have an average transmission above about 95%. The notch filters exhibit a blocking of OD>6, very high transmission (>90%) outside the notch(es), and a narrow notch bandwidth comparable to that of holographic notch filters. The methods for making such filters accurately determine when deposition of each layer of the filter should terminate.

53 Claims, 18 Drawing Sheets



OTHER PUBLICATIONS

Macleod, H. Angus, "Turning value monitoring of narrow-band all-dielectric thin-film optical filters," *Optica Acta*, vol. 19, pp. 1-28 (1972).

Press, W.H., et al., The Levenberg-Marquardt method implemented under the name "mrqmin()", *Numerical Recipes in C: The Art of Scientific Computing*, 2nd ed., Chapter 15, pp. 683-688 (1995).

Martin, P.J. et al., "Ion-beam-assisted deposition of thin films," *Applied Optics*, vol. 22, No. 1, pp. 178-184 (1983).

"Interference Filters," Melles Griot, pp. 13.25-13.29.

J.M.E. Harper, "Ion Beam Deposition," In *Thin Film Processes*, Ed. by J.L. Vossen and W. Kern, pp. 175-206 (Academic Press, New York, 1978).

U.J. Gibson, "Ion-Beam Processing of Optical Thin Films," in *Physics of Thin Films*, vol. 13, Ed. by G. Hass and M.H. Fancome, pp. 109-150 (Academic Press, New York, 1978).

J.M.E. Harper et al., "Modification of Thin Film Properties by Ion Bombardment During Deposition," in *Ion Bombardment Modification of Surfaces*, Ed. by O. Auciello and R. Kelly, from *Beam Modification of Materials*, vol. 1, pp. 127-162 (Elsevier, Amsterdam, 1984).

W.H. Press et al., *Numerical Recipes*, "Numerical Recipes in C: The Art of Scientific Computing," 2nd ed., Cambridge University Press, Cambridge, Chapter 15.7, pp. 699-706 (1995).

* cited by examiner

Fig. 1A

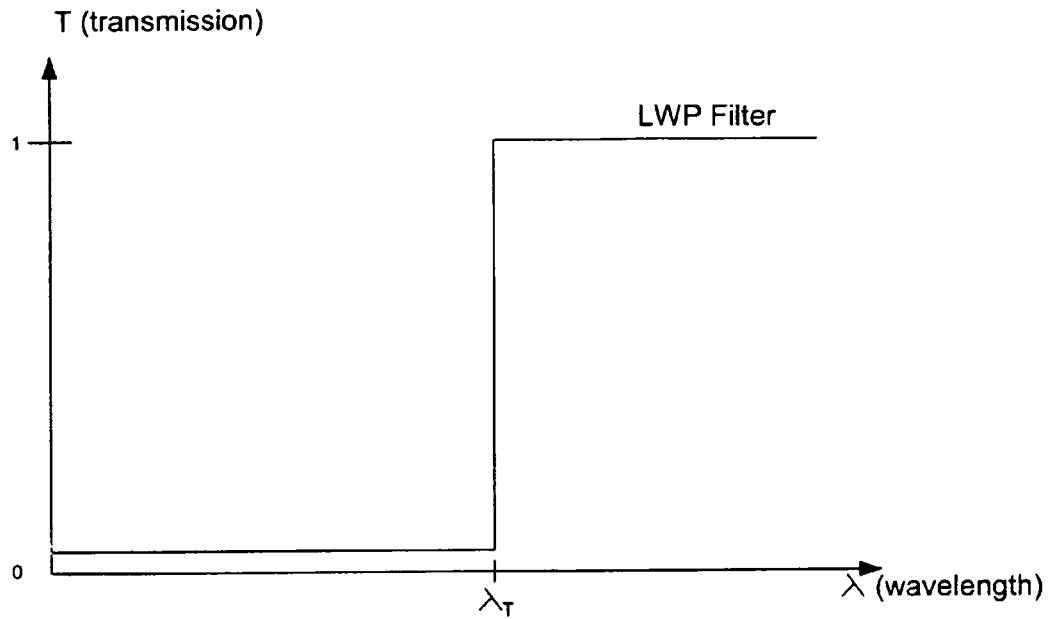


Fig. 1B

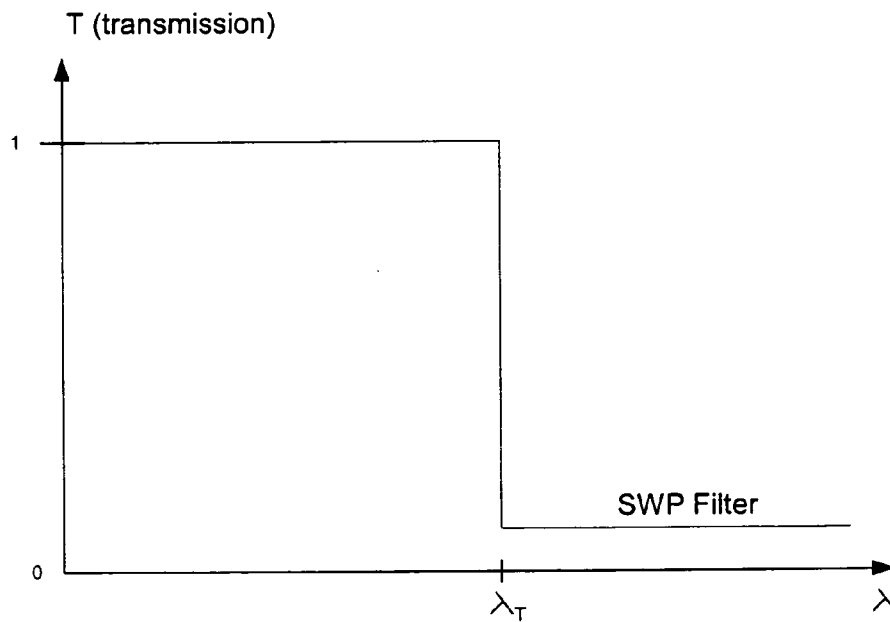


Fig. 1C

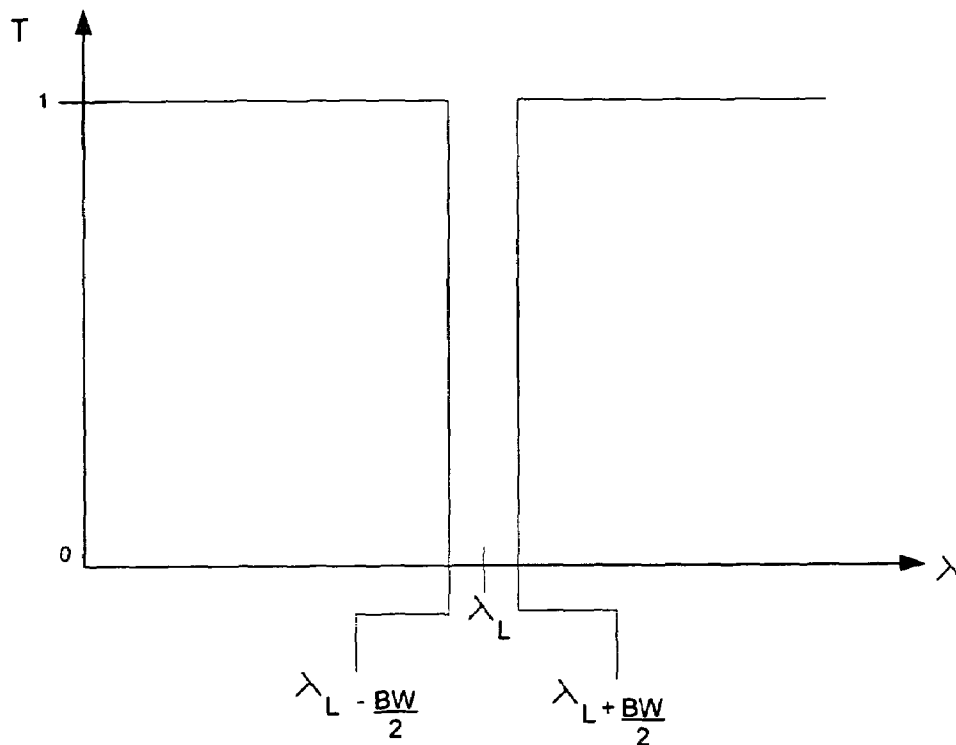


Fig. 1D

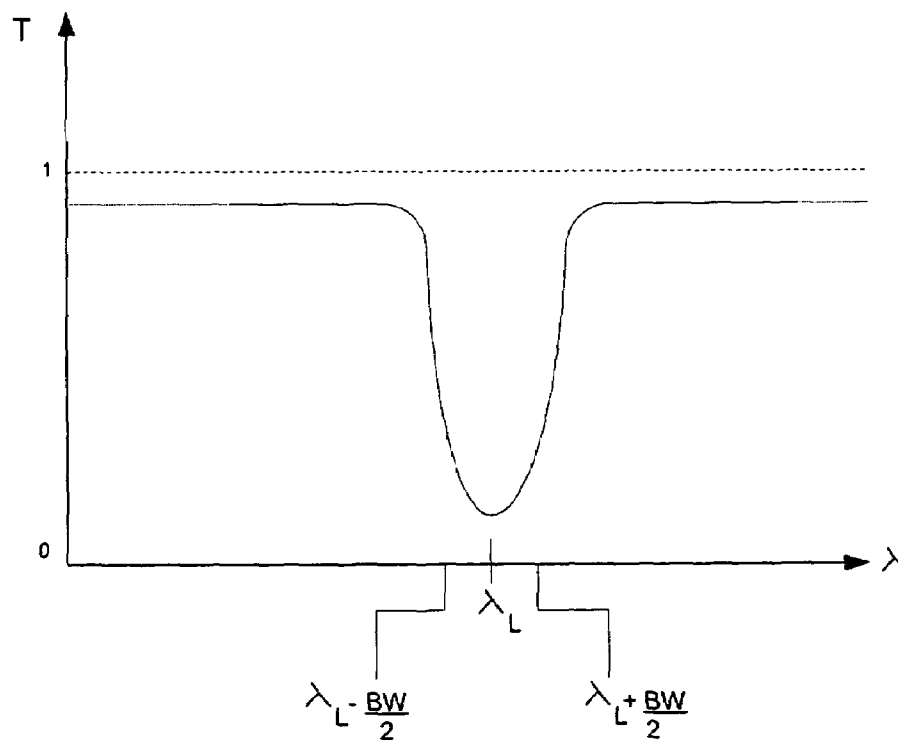


Fig. 2

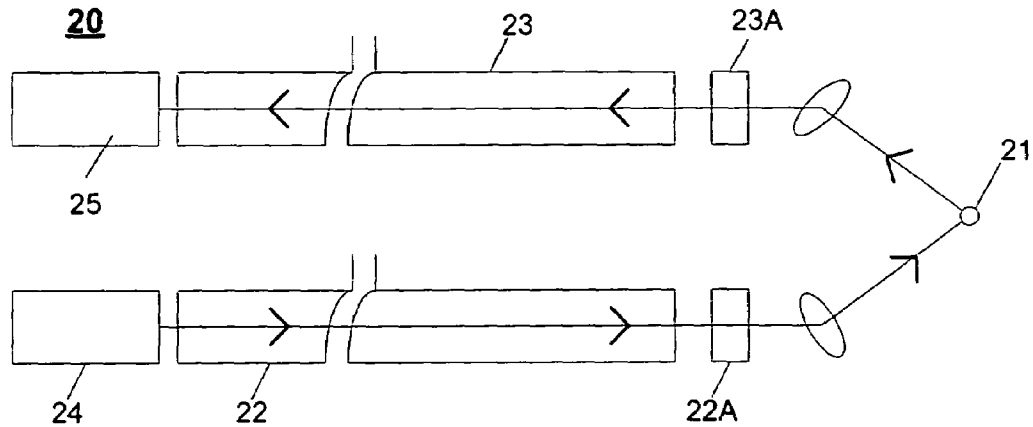
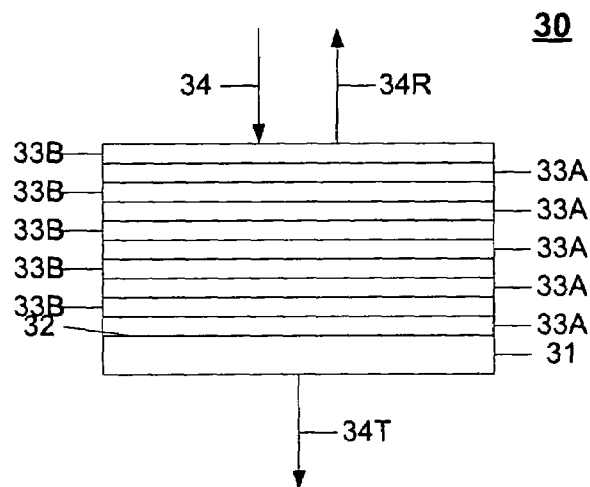


Fig. 3



Explore Litigation Insights

Docket Alarm provides insights to develop a more informed litigation strategy and the peace of mind of knowing you're on top of things.

Real-Time Litigation Alerts



Keep your litigation team up-to-date with **real-time alerts** and advanced team management tools built for the enterprise, all while greatly reducing PACER spend.

Our comprehensive service means we can handle Federal, State, and Administrative courts across the country.

Advanced Docket Research



With over 230 million records, Docket Alarm's cloud-native docket research platform finds what other services can't. Coverage includes Federal, State, plus PTAB, TTAB, ITC and NLRB decisions, all in one place.

Identify arguments that have been successful in the past with full text, pinpoint searching. Link to case law cited within any court document via Fastcase.

Analytics At Your Fingertips



Learn what happened the last time a particular judge, opposing counsel or company faced cases similar to yours.

Advanced out-of-the-box PTAB and TTAB analytics are always at your fingertips.

API

Docket Alarm offers a powerful API (application programming interface) to developers that want to integrate case filings into their apps.

LAW FIRMS

Build custom dashboards for your attorneys and clients with live data direct from the court.

Automate many repetitive legal tasks like conflict checks, document management, and marketing.

FINANCIAL INSTITUTIONS

Litigation and bankruptcy checks for companies and debtors.

E-DISCOVERY AND LEGAL VENDORS

Sync your system to PACER to automate legal marketing.